

Docket No. 245557US0S X

IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

IN RE APPLICATION OF: Masanobu OGINO, et al.

SERIAL NO: 10/713,054

GAU: 2813

FILED: November 17, 2003

EXAMINER: NGUYEN, T. T.

FOR: SEMICONDUCTOR SUBSTRATE AND METHOD OF MANUFACTURE THEREOF

**REQUEST FOR EXTENSION OF TIME
UNDER 37 C.F.R. 1.136**

COMMISSIONER FOR PATENTS
ALEXANDRIA, VIRGINIA 22313

SIR:

It is hereby requested that a **two** month extension of time be granted to January 10, 2008 for

- ☐ filing a response to the Official Action dated:
- ☐ responding to the requirements in the Notice of Allowability dated:
- ☐ filing the Formal Drawings. The Issue Fee due has been timely filed.
- ☐ responding to the Notice to File Missing Parts of Application dated:
- ☒ filing a Notice of Appeal. A timely response to the final rejection was filed on November 13, 2007. A Request for Continued Examination is being filed concurrently herewith.
- ☐ filing an Appeal Brief. A Notice of Appeal was filed on:
- ☐ Applicant claims small entity status. See 37 CFR 1.27. Therefore, the fee amount shown below is reduced by one-half.

The required fee of \$460.00 is being made by credit card payment and any further charges may be made against the Attorney of Record's Deposit Account No. **15-0030**.

Respectfully Submitted,

OBLON, SPIVAK, McCLELLAND,
MAIER & NEUSTADT, P.C.
Norman F. Oblon



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